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Microstructural study of nanocrystalline pure and doped tin dioxide to be used for resistive gas sensors

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ABSTRACT

Nanocrystalline pure and doped SnO₂ have been intensively studied for a long time to build resistive gas sensors. However, it is still useful to synthesize nanopowders with the smallest crystallite size to build devices. A modified gel-combustion method and a novel reactive oxidation process are proposed for nanopowders synthesis and results are compared. Materials have been characterized by XRD, Scherrer equation to evaluate the crystallite size; BET absorption to determine specific area and HRTEM to observe the crystallites (evaluating their mean size and distribution); defects and effect of calcination treatments are also considered. Previous studies have shown that if nano-SnO₂ replaces the conventional microcrystalline-SnO₂ to build resistive gas sensors, sensitivity increases (>30%) and the operation temperature considerably decreases.

A heating and measuring system has been designed for achieving low power consumption and uses pulsed heating operation. This method of electrical control and measurement is operated intermittently, with "heating" and "readout" cycles (readout: signal of sensitive film).

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1. Introduction

Tin dioxide semiconductor (SC) has been used to build gas sensors for many years, exhibiting interesting properties which considerably change as the SnO₂ grain size decreases to nanometric dimension. Pure and doped nano semiconductors were studied and already applied for resistive gas sensors [1-7]. The replacement of the conventional microcrystalline pure or doped SnO₂ by the same material but nanocrystalline to build the gas sensors, has driven to interesting results since the sensor sensitivity increased (30-37%) and the operation temperature (T_{op}) considerably decreased from 350-450 °C to a range: 250-350 °C for nanocrystalline Al-doped SnO₂, and similarly for In doped SnO₂. Fig. 1 or to 180-220 °C for pure nano-SnO₂ [8–10], Fig. 2. The gas detection process is affected by several factors, among them the microstructure. The metallic oxide previously reacts with the air oxygen forming at the SCsurface oxygen adsorbates, $(0^-, 0_2^-, 0^{2^-})$ [11–13] which play an important role in gas sensing (being the O⁻ the most active). The adsorbates cover the SC-surface and the grain boundaries and react at the $T_{op} \sim 350-450$ °C if the sensor is built with microcrystalline

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http://dx.doi.org/10.1016/j.snb.2014.10.104 0925-4005/© 2014 Elsevier B.V. All rights reserved. semiconductor. In case of *n*-type SC metallic oxides, the formation of these adsorbates builds a space–charge region, resulting in an electron-depleted surface layer (space–charge) due to the electron transfer to the adsorbate as follows:

$$O_2(g) + 2e^- = 2O^-(adsorb.)$$
 (1)

The depth of the space–charge is a function of the surface coverage with the oxygen adsorbates and of the intrinsic electron concentration in the bulk. The resistance of the *n*-type SC is, in consequence, high because a potential barrier to the electronic conduction is formed at each grain boundary [11]. If the sensor is exposed to a reducing gas (i.e. CO) at the T_{op} , the gas reacts with oxygen adsorbate (O⁻) according to:

$$CO + O^{-} = CO_{2} + e^{-}$$
⁽²⁾

The oxygen adsorbates are consumed by the subsequent reactions, so that a lower steady-state is established, the potential barrier height decreases and a resistance drop is produced, being the resistance variation the measuring parameter of sensor. A simple schematic model for grain-size affecting the surface resistivity was proposed by Yamazoe et al. [11] concluding that the sensor sensitivity increases as grain size decreases. The sensor sensitivity (*S*) can be defined as: $S = R_{air}/(R_{air+gas})$, where: R_{air} is the resistance in air and R_{gas} is the resistance in a gas sample containing a reducing

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Fig. 1. Sensor response to 20 ppm CO (g) for doped SnO₂ (at%) vs. T_{op} (°C).



Fig. 2. Sensor sensitivity to 5 ppm H_2 for pure SnO₂ vs. T_{op} (°C).

component. The reactivity of the oxygen adsorbates is a function of the type of reducing gas and of sensor temperature.

The aim of this work was to analyze the structure and morphology of pure and doped (with Al or In) nanocrystalline SnO_2 with different crystallite diameters (ϕ), to be applied for gas sensors. Nanomaterials were prepared by gel-combustion [14] and/or by reactive oxidation with H_2O_2 [15] and results of both methods were compared with similar results [7]. Characterization was performed by X-ray diffraction (XRD), Brunauer–Emmer–Teller isotherms (BET) method and High Resolution Transmission Electron Microscopy (HRTEM).

2. Experimental

2.1. Pure SnO₂ synthesis

Pure SnO₂ nanopowders were synthesized by two techniques and results are compared as described in [7]: reactive oxidation with H_2O_2 [15] and modified nitrate-citrate gel combustion [14]. In the first method, the SnCl₂ reacts with H_2O_2 treating afterwards the product with (NH₄)OH in H_2O_2 medium. Stannic acid is produced giving nanopowdered SnO₂ by calcination:

 $SnCl_2 + H_2O_2 \rightarrow SnOCl_2 + H_2O_2$

$$\text{SnOCl}_2 + 2(\text{NH}_4)\text{OH} \xrightarrow{\text{H}_2\text{O}_2} \text{SnO}_3\text{H}_2 + 2(\text{NH}_4)\text{Cl} \xrightarrow{\text{calcination}} \text{SnO}_2$$

The violent oxidation reaction with H_2O_2 disintegrates the product particles vielding small crystallites with diameters: 2–9 nm.

The gel-combustion, fuel-rich synthesis [14] starts with the preparation of a precursor: (aqueous solution with p/a metallic Sn), 70% - HNO₃, CH₃COOH and 25% - NH₄·OH. Citric acid is the organic fuel; [tin/fuel] ratio = 1:6. The pH was increased with (NH4) OH (approaching to neutrality and keeping the solution homogeneity). The solution is thermally evaporated till turning into a gel. If heating is sustained, gel turns into a darken foam which ignites. The intense combustion of the final stage is due to a highly exothermic redox reaction between the oxidizing nitrate ions and the organic fuel. TGA plots of gellified samples show that gels usually liquefy at \sim 80 °C and ignition starts at \sim 200–300 °C. Combustion usually promotes an ignition not depending on atmospheric oxygen supply, since the foam bubbles are filled either with NH₄NO₃ vapours or NO_x $(1 \le x \le 2)$ restricting the oxygen access to the bottom of reaction container. Combustion duration is short: usually, half of a minute. Gas liberation promotes the fast disintegration of precursor gel at high temperature causing decomposition. If the oxide contains carbonaceous residues by a fuel surplus, they are removed by calcination and nanometric crystallites (9-15 nm) are produced. Parameters to be fitted are: organic fuel type, combustion temperature and process duration. After the synthesis, the crystallites size and homogeneity, their morphology and the impurities retention during the synthesis process have been evaluated.

2.2. Doped SnO₂ synthesis

The gas sensor to detect hydrogen was built with nanocrystalline pure SnO₂ [9] CO (g) ppm was built with Al-doped nanocrystalline SnO₂ [8] and that for VOCs sensing [10]. The method to prepare the two first materials was gel-combustion using CH₃COOH as fuel and the crystallite size resulted: 2–4 nm. In case of In-doped nanocrystalline SnO₂ [10] the synthesis method consisted in precipitating together p/a SnCl₂·2H₂O and InCl₃, in NH₄NO₃ medium to produce stannic oxo-hydroxide which was intensively oxidized with 30–250 vol H₂O₂ thus obtaining stannic acid as nanocrystalline powder. This solution was precipitated with (NH₄)OH to get an homogeneous compound of stannic acid and indium hydroxide. The resulting crystallite size was ~2–4 nm.

2.3. Characterization of nanomaterials

XRD enabled to identify the material, to evaluate the crystalline structure and to measure crystallites size by application of Scherrer equation; BET measurements were used to determine the specific area and HRTEM, Fig. 3a and b, enabled to observe the crystallites morphology, size and distribution and the calcination temperature effects.

2.4. Sensors building and heating/measuring system

This item is a brief description of functional principle of the sensor gas by direct contact.

In case of using pure or doped nano-SnO₂ to build the sensor and to reduce the power consumption, an innovative heater and measurement device [16], similar to those used for thin film sensors [17], was developed with MEMS Technology (Closed Membrane Type).

The sensor can work in pulsed mode, just as other sensors do, similar to those of the international market. But, differing with them, the sensor described in this work exhibit direct thermal and electrical contact with the sensitive film. This fact enables to reduce a step in the manufacturing process because it is not necessary to isolate the sensitive film and the heater (passivation layer and annealing are not required). This situation improves the efficiency

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